

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The Patent Application of:
Shunpei YAMAZAKI et al.
Serial No. 09/894,125
Filed: June 29, 2001
For: CRYSTALLINE SEMICONDUCTOR
THIN FILM, METHOD OF
FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SAME

) Group Art Unit: 2823
) Examiner: B. Kebede
) CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2003.

<u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Further in response to the Official Action dated May 21, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.